

In re the Application of: Kenji NISHI et al.

Group Art Unit: 2851

Serial No.: 10/718,728

Examiner: Hung Henry V. Nguyen

Filed: November 24, 2003

Confirmation No.: 1835

AN EXPOSURE APPARTUS, EXPOSURE METHOD USING THE SAME, AND METHOD OF MANUFACTURE OF CIRCUIT DEVICE

> Attorney Docket Number: 991185B

Customer Number: 38834

## RESPONSE UNDER 37 C.F.R. §1.116 - EXPEDITED RESPONSE -

Mailstop AF Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

January 14, 2005

Sir:

In response to the Quayle Action dated October 20, 2004, Applicants amend the application as follows and submit the following remarks.

Amendments to the Abstract begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims that begins on page 3 of this paper.

Remarks/Arguments begin on page 9 of this paper.